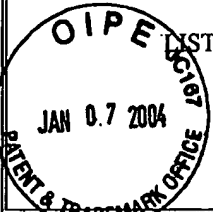


U.S. Department of Commerce, Patent and Trademark Office		Docket No.: 4448/Y01/CPS/IBSS/LAP	Serial No.: 09/706,435
 <p>LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)</p>		Applicant(s): Ronald Schauer and John Charles Davies	
		Filing Date: 11/03/00	Group: 3632

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Wm</i>	AA	4,852,516	08/01/89	Rubin et al.			
<i>Wm</i>	AB	5,733,024	03/31/98	Slocum et al.			
<i>Wm</i>	AC	6,133,981	10/17/00	Semba			
	AD						
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	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL	EP 1 107 288 A2	06/13/01	EPO			X	
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	United States Patent Application Publication No.: US 2002/0084402 A1, dated July 4, 2002
AS	
AT	

Examiner <i>Mars</i>	Date Considered <i>3/18/04</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.